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2814
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of)
Kazuo MAEDA) Examiner: Quach
Serial No.: 09/519,599 /) Art Unit: 2814
Filed: March 6, 2000)
For: METHOD AND APPARATUS FOR)
FORMING AN INTERLAYER)
INSULATING FILM AND)
SEMICONDUCTOR DEVICE)

RESPONSE TO OFFICE ACTION OF APRIL 23, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the office action of April 23, 2003, please amend the captioned application as follows:

RECEIVED
AUG 18 2003
TECHNOLOGY CENTER 2800